

(19)



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(11)

**EP 0 823 714 B1**

(12)

## EUROPEAN PATENT SPECIFICATION

(45) Date of publication and mention  
of the grant of the patent:  
**13.03.2002 Bulletin 2002/11**

(51) Int Cl.7: **H01F 10/06**, H01F 10/12,  
H01F 17/04, H01F 27/28,  
H01F 10/18

(21) Application number: **97305953.8**

(22) Date of filing: **05.08.1997**

### (54) **Thin magnetic element and transformer**

Dünnschicht magnetisches Element und Transformator

Elément magnétique mince et transformateur

(84) Designated Contracting States:  
**DE FR GB NL SE**

(30) Priority: **08.08.1996 JP 21030896**

(43) Date of publication of application:  
**11.02.1998 Bulletin 1998/07**

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(56) References cited:  
• **PATENT ABSTRACTS OF JAPAN** vol. 006, no.  
145 (P-132), 4 August 1982 & JP 57 066523 A  
(HITACHI LTD), 22 April 1982,  
• **K.TERUNUMA ET AL: "Effects of Addition of Zr  
and Ti on sputtered Fe-N films" IEEE  
TRANSLATION JOURNAL ON MAGNETICS IN  
JAPAN., vol. 6, no. 1, January 1991, NEW YORK  
US, pages 23-28, XP000242186**  
• **MAKINO A ET AL: "MICROSTRUCTURE AND  
CRYSTALLIZATION BEHAVIOR OF FE-M-O  
(M=HF,ZR) FILMS WITH HIGH RESISTIVITY"  
IEEE TRANSLATION JOURNAL ON MAGNETICS  
IN JAPAN, vol. 9, no. 6, 1 November 1994, pages  
281-285, XP000548761**

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## Description

[0001] This invention relates to a thin magnetic element comprising a coil pattern formed on a substrate and a thin magnetic film formed on the coil pattern; and a transformer equipped with the element.

[0002] Reflecting the size reduction and performance improvement of a magnetic element, a soft magnetic material is required, particularly, to have a high saturation magnetic flux density of 5 kG or higher and at the same time, high specific resistance and low coercive force. In a transducer, among various applications, a soft magnetic material having a high specific resistance is especially requested.

[0003] As magnetic materials having a high saturation magnetic flux density, Fe and a number of alloys composed mainly of Fe are known. When manufactured using such an alloy by the film forming technique such as sputtering method, the thin magnetic film so obtained has a high coercive force and small specific resistance in spite of a high saturation magnetic flux density and it is difficult to obtain good soft magnetic properties in a high frequency region. In addition, ferrite frequently employed as a bulk material does not provide excellent soft magnetic properties when formed into a thin film.

[0004] As one of the causes for the reduction of the magnetic permeability at high frequency is the loss caused by the generation of eddy currents. For the prevention of such an eddy current loss which is one of the causes for the reduction the magnetic permeability at high frequency, there is accordingly a demand for a reduction in the film thickness and an increase in the resistance of a thin film.

[0005] It is however very difficult to heighten the specific resistance while maintaining the magnetic properties. A soft thin magnetic film formed of a crystal alloy, for example, Sendust or an amorphous alloy has a specific resistance as small as several tens of  $\mu\Omega\cdot\text{cm}$ . There is accordingly a demand for soft magnetic alloys having an increased specific resistance with a saturation magnetic flux density being maintained at 5 kG (0.5T) or greater.

[0006] When a soft magnetic alloy is formed into a thin film, it becomes more difficult to obtain good soft magnetic properties owing to an influence of the generation of magnetostriction, or the like.

[0007] Particularly in the case where a thin magnetic element is formed by disposing a thin film of a soft magnetic alloy close to a coil, it is still more difficult to obtain a high inductance and figure of merit while maintaining good soft magnetic properties which the soft magnetic alloy originally has possessed and also to control a temperature rise during use. In the conventional thin magnetic element of such a type, a loss increase occurs in the thin film formed of a soft magnetic alloy prior to the lowering in the figure of merit Q of a coil itself constituting a magnetic core, resulting in the tendency to limit the high-frequency properties which a transducer or reactor should have as a thin magnetic film. In other words, the application, as a thin magnetic film, of a Co-group amorphous thin film, a Ni-Fe alloy thin film or the like which has excellent soft magnetic properties can be considered but such a thin film does not have a high specific resistance and is apt to increase a loss at high frequency, whereby the high frequency properties of the entire magnetic element tend to be limited.

[0008] Such conventional magnetic thin films are discussed in D W Rice et al, Magnetic corrosion and surface properties of Ni-Fe-Cr thin films, Journal of Applied Physics, Vol 47, No 3, March 1976.

[0009] With the foregoing in view, the present invention has been completed. An object of the present invention is to provide a thin magnetic element which can be reduced in its thickness, exhibits a high inductance and figure of merit Q, can meet the use at a high frequency region and does not emit heat so much; and also to provide a transformer equipped with the thin magnetic element.

[0010] With a view to overcoming the above-described problems, the present invention, in a first aspect, provides a thin magnetic element comprising a coil pattern formed on at least one side of a substrate and a thin magnetic film formed on the coil pattern, wherein: said thin magnetic film is formed to a thickness of 0.5  $\mu\text{m}$  or greater but 8  $\mu\text{m}$  or smaller; and at least one of the following conditions is satisfied; assuming that the thickness and width of one winding of the coil are "t" and "w", respectively, the aspect ratio t/w of the coil satisfies the relationship of  $0.035 \leq t/w \leq 0.35$ ; and assuming that the width of one winding of the coil constituting the coil pattern is w and the distance between one whole coil and the next coil in the coil pattern is "b", the relationship of  $0.2 < w/(w+b)$  is satisfied, wherein; the thin magnetic film comprises a fine crystalline phase which is composed mainly of at least one element selected from the group consisting of Fe, Co and Ni and has an average grain size of 30 nm; and an amorphous phase which is composed mainly of a compound formed of at least one element selected from the group consisting of lanthanide type rare earth elements (at least one of La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm and Lu), Ti, Zr, Hf, Ta, Nb, Mo and W and O or N.

[0011] A good figure of merit Q can be attained by forming the thin magnetic film on the coil pattern to the above-described thickness; a temperature rise of the coil conductor can be suppressed by setting the aspect ratio of the coil conductor within the above-described range; and a stably high inductance, low equivalent resistance and good figure of merit Q can be achieved by satisfying the relationship of  $0.2 \leq w/(w+b)$ .

[0012] In a second aspect, the invention provides a transformer, comprising coil patterns formed on both sides of a substrate and thin magnetic films formed on the coil patterns, wherein: each of said thin magnetic films is formed to a

thickness of 0.5  $\mu\text{m}$  or greater but 8  $\mu\text{m}$  or smaller; and at least one of the following conditions is satisfied: assuming that the thickness and the width of one winding of the coil constituting the coil pattern are  $t$  and  $w$ , respectively, an aspect ratio  $t/w$  of the coil satisfies the relationship of  $0.035 \leq t/w \leq 0.35$ ; and assuming that the width of one winding of the coil constituting the coil pattern is  $w$  and the distance between one whole coil and the next in the coil pattern is  $b$ , the relationship of  $0.2 < w/(w+b)$  is satisfied, wherein; the thin magnetic film comprises a fine crystalline phase which is composed mainly of at least one element selected from the group consisting of Fe, Co and Ni and has an average grain size of 30 nm and an amorphous phase which is composed mainly of a compound formed of at least one element M selected from the group consisting of lanthanide type rare earth elements (at least one of La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm and Lu), Ti, Zr, Hf, Ta, Nb, Mo and W and O or N.

**[0013]** The use of a thin magnetic film having such a constitution or such compounding ratios makes it possible to increase the specific resistance of the thin magnetic film itself, reduces the loss in the high frequency region and decreases the limitations in the high frequency region which the conventional material has.

**[0014]** Embodiments of the invention will now be described, by way of example only, with reference to the accompanying drawings, in which:

FIG. 1 is a cross-sectional view illustrating one embodiment of the thin magnetic element according to the present invention;

FIG. 2 is a plan view of the coil conductor which is disposed on the thin magnetic element illustrated in FIG. 1;

FIG. 3 is a graph showing a dependence, on the thickness of the magnetic layer, of the upstream figure of merit of a thin magnetic element sample;

FIG. 4 is a graph showing the relationship between the inductance and the conductor width of the thin magnetic element sample;

FIG. 5 is a graph showing the relationship between the equivalent resistance and the conductor width of the thin magnetic element sample;

FIG. 6 is a graph showing the relationship between the figure of merit  $Q$  and the conductor width of the thin magnetic element sample;

FIG. 7 is a graph showing the relationship between the current and the temperature rise of the thin magnetic element sample in the case where the coil conductor thickness is 35  $\mu\text{m}$ ; and

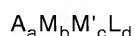
FIG. 8 is a graph showing the relationship between the current and the temperature rise of the thin magnetic element sample in the case where the coil conductor thickness is 70  $\mu\text{m}$ .

**[0015]** FIGS. 1 and 2 each illustrate a first embodiment of the present invention. A thin magnetic element A of this type is formed by stacking a thin magnetic film 3 and an insulation film 4 on the surfaces of substrates 1, 2 opposite to each other and disposing coil conductors 6,6 with a flexible substrate 5, which has been arranged between the up-and-down insulation films 4,4, therebetween. FIG. 2 is a plan view of a coil 7 formed of the above-described coil conductor 6 and the coil conductor 6 in this embodiment is in a quadrate spiral shape. Incidentally, the coil conductor is not limited by that illustrated in FIG. 2 but any shape of meander and a combination of spiral and meander can be employed.

**[0016]** The substrates 1, 2 are each formed of an insulating nonmagnetic material such as resin, for example, polyimide or ceramic.

**[0017]** The thin magnetic film 3 is formed of the below-described special soft magnetic material having a high specific resistance.

**[0018]** Assuming that A represents at least one element selected from the group consisting of Fe, Co and Ni, M represents at least one element selected from the group consisting of lanthanide type rare earth elements (at least one of La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm and Lu), Ti, Zr, Hf, V, Nb, Ta and W, M' represents at least one element selected from the group consisting of Al, Si, Cr, Pt, Ru, Rh, Pd and Ir; and L represents at least one element selected from O and N, the special soft magnetic material constituting the thin magnetic film 3 is represented by the following composition formula:



**[0019]** In the above composition formula,  $a$ ,  $b$ ,  $c$  and  $d$  which show the compounding ratios preferably satisfy the following relationships:

**[0020]**  $20 \leq a \leq 85$ ,  $5 \leq b \leq 30$ ,  $0 \leq c \leq 10$  and  $15 < d < 55$ , each in atomic %. It is more preferred that the thin magnetic film has the above-described composition and is formed of a fine crystalline phase which is composed mainly of at least one element selected from the group consisting of Fe, Co and Ni and has an average grain size of 30 nm or smaller and an amorphous phase which is composed mainly of a compound consisting of elements M and O or a

compound consisting of elements M and N.

**[0021]** Described specifically, when the thin magnetic film 3 is formed of a material having a composition represented by the following formula:  $\text{Fe}_e\text{M}_f\text{O}_g$  wherein M is the rare earth element, it is more preferred that the compounding ratios, e, f and g, satisfy the following relationships:  $50 \leq e \leq 70$ ,  $5 \leq f \leq 30$  and  $10 \leq g \leq 40$ , each in atomic %.

**[0022]** When the thin magnetic film 3 is formed of a material having a composition represented by the following formula:  $\text{Fe}_h\text{M}_i\text{O}_j$  wherein M is at least one element selected from the group consisting of Ti, Zr, Hf, V, Nb, Ta and W, it is more preferred that the compounding ratios, h, i and j, satisfy the following relationships:  $45 \leq h \leq 70$ ,  $5 \leq i \leq 30$  and  $10 \leq j \leq 40$ , each in atomic %.

**[0023]** When the thin magnetic film 3 has a composition represented by the following formula:  $\text{Fe}_k\text{M}_l\text{N}_m$ , it is more preferred that the compounding ratios, k, l and m, satisfy the following relationships:  $60 \leq k \leq 80$ ,  $10 \leq l \leq 15$  and  $5 \leq m \leq 30$ .

**[0024]** The above-described insulation film 4 is composed of an insulation material such as  $\text{SiO}_2$ ,  $\text{Al}_2\text{O}_3$ ,  $\text{Si}_3\text{N}_4$  or  $\text{Ta}_2\text{O}_5$ .

**[0025]** Among the materials constituting the thin magnetic film, Fe is a main component and is an element responsible for the magnetism. A greater content of Fe is preferred to obtain a high saturation magnetic flux density, however, an Fe content exceeding 70 atomic % in the Fe-M-O system or that exceeding 80 atomic % in the Fe-M-N system tends to decrease the specific resistance. An Fe content less than the above range, on the other hand, inevitably reduces the saturation magnetic flux density even though the specific resistance can be increased.

**[0026]** An element M selected from the group consisting of the rare earth elements, Ti, Zr, Hf, V, Nb, Ta and W is necessary for obtaining soft magnetic properties. These elements are apt to bond with oxygen or nitrogen and form an oxide or nitride by binding. Incidentally, further examples of the elements apt to bond with oxygen or nitrogen include Al, Si and B.

**[0027]** The specific resistance can be increased by adjusting the oxide or nitride content. The element M' is an element added to improve the corrosion resistance and to adjust the magnetostriction. It is preferred to add these elements within the above-described range for such purposes.

**[0028]** Within the above composition range, a thin magnetic film having a specific resistance falling within a range of 400 to  $2.0 \times 10^5 \mu\Omega\cdot\text{cm}$  can be obtained and by the heightening of the specific resistance, it is possible to reduce eddy current loss, to suppress lowering of the high frequency magnetic permeability and to improve high frequency properties. In addition, particularly Hf is considered to have magnetostriction suppressing effects.

**[0029]** In the above constitution, the thin magnetic film 3 is preferably formed to a thickness of 0.5  $\mu\text{m}$  or greater but 8  $\mu\text{m}$  or smaller. Within this range, the figure of merit Q not lower than 1.5 can be obtained. If the film thickness is 1  $\mu\text{m}$  or greater but 6  $\mu\text{m}$  or smaller, the figure of merit Q not lower than 2 can be attained. In either case, a good figure of merit Q can be attained. Assuming that the thickness of the coil conductor 6 constituting the above-described coil pattern is "t" and its width is "w", :

the aspect ratio t/w of the coil conductor 6 satisfies the following relationship  $0.035 \leq t/w \leq 0.35$ . By controlling the aspect ratio of the coil conductor to fall within the above-described range, the temperature rise of the coil conductor can be suppressed.

**[0030]** Assuming that the width of the coil conductor 6 constituting the above-described coil pattern is "w" and in the coil pattern, the distance between the mutually adjacent coil conductors 6,6 is "b", the ratio of the coil conductor, that is, w/(w+b) satisfies the following relationship:  $0.2 \leq w/(w+b)$ . It is possible to obtain a stable inductance, a low equivalent resistance and a good figure of merit Q when the relationship of  $0.2 \leq a/(a+b)$  is satisfied.

**[0031]** For the fabrication of the thin magnetic element A having the above-described constitution, first a thin magnetic film 3 composed of a highly-resistant (high- $\rho$ ) A-M-M'-L base soft magnetic alloy is formed on one side of each of the substrates 1,2.

**[0032]** For that purpose, a thin film formation method such as sputtering or vapor deposition is basically employed.

**[0033]** Here, existing sputtering apparatuses such as RF double-pole sputtering, DC sputtering, magnetron sputtering, triple-pole sputtering, ion beam sputtering or target-opposed type sputtering can be employed for example.

**[0034]** In the next place, as a method to add O or N to the thin magnetic film, effectively usable is reactive sputtering in which sputtering is conducted in an  $\text{Ar} + \text{O}_2$  or  $\text{Ar} + \text{N}_2$  mixed gas atmosphere having an oxygen gas or nitrogen gas mixed in an inert gas such as Ar. It is also possible to prepare, in an inert gas such as Ar, a thin magnetic film by employing a composite target having Fe, an element M or an oxide or nitride thereof arranged on a target of Fe, FeM or FeM base alloy. Alternatively, it is possible to prepare, in an inert gas such as Ar, a thin magnetic film by employing, as a sputtering target, a composite target, which has, on a Fe target, a pellet composed of the rare earth element, Ti, Zr, Hf, V, Nb, Ta or W. The thin magnetic film of the above-described composition obtained by such a film formation method is formed mainly of an amorphous phase or formed of a crystalline phase and an amorphous phase existing as a mixture, before annealing treatment.

**[0035]** After a thin magnetic film having the desired composition is formed, it is subjected to the annealing treatment, more specifically, heating to 300 to 600°C and then slow cooling, whereby a fine crystalline phase can be formed by

precipitation in the thin magnetic film.

**[0036]** It is also possible to form a crystalline phase by subjecting the above-described thin soft magnetic film to the annealing treatment to cause partial precipitation and in this case, it is preferred to control the ratio of the crystalline phase to less than 50%. Ratios of the crystalline phase exceeding 50% lead to lowering in the magnetic permeability in the high frequency region. Here, the crystal grains precipitated in the texture have a grain size as fine as several nm to 30 nm and it is preferred that its average grain size is 10 nm or smaller. Precipitation of such fine crystal grains makes it possible to heighten the saturation magnetic flux density. The amorphous phase, on the other hand, is considered to contribute to an increase in the specific resistance so that owing to the existence of this amorphous phase, the specific resistance increases, leading to the prevention of a reduction in the magnetic permeability in the high frequency region.

**[0037]** On the above-described thin magnetic film 3, an insulation film 4 is formed in a manner known per se in the art such as film formation method, plating method or screen printing method, followed by the formation of a coil conductor 6 to obtain, for example, a spiral type coil 7 in a manner known per se in the art such as film formation method, plating method or screen printing method. Then the substrates 1,2 having the coil conductors 6 formed thereon are disposed on upper and lower sides of the substrate 5 so that the substrate 5 is interposed between the substrates 1,2, whereby a thin magnetic element A can be obtained.

**[0038]** In the case of a thin magnetic element A having the structures as shown in FIG. 1 and FIG. 2, either one of the coil conductors 6,6 can be used as a primary coil and the coil conductor on the other side can be used as a secondary coil, which enables the use of the thin magnetic element A as a transformer. In particular, by making effective use of the excellent properties of the thin magnetic film 3, as described above, at high frequency, the film can be applied to a small-sized, thin-type and highly-efficient transformer for DC-DC converter or reactor inductor which is driven at a switching frequency not lower than 1 MHz. When a thin magnetic film 3, an insulation film 4 and a coil 7 are formed on only one side of the substrate 5, the resulting thin magnetic element A can be used as an inductor.

**[0039]** In the conventional thin magnetic element, a large eddy current is generated around the coil, leading to a loss. If the above-described thin magnetic film 3 having a high specific resistance is employed, it is possible to provide a thin magnetic element A which is suppressed in the generation of an eddy current in a high frequency region and is therefore suppressed in a loss. In addition, since the loss of the thin magnetic element A can be controlled to be low, the thin magnetic element A and a transformer equipped therewith can be formed to be tolerable against a large electric power, resulting in the actualization of reductions in the thickness, size and weight.

**[0040]** Incidentally, the soft magnetic material constituting the thin magnetic film 3 and having the above-described composition has a sufficiently high specific resistance.

**[0041]** In Table 1, examples of the materials constituting the thin magnetic film 3 are shown. Each sample was prepared by carrying out sputtering in an atmosphere composed of Ar and 0.1 to 1.0% oxygen (O) using an RF magnetron sputtering apparatus and a composite target having a pellet of M or M' on a Fe target. Sputtering time was adjusted so that the film thickness would be about 2  $\mu\text{m}$ . Sputtering conditions are as follows:

Preliminary gas exhibit:  $1.3 \times 10^{-4} \text{ Pa}$  ( $1 \times 10^{-6} \text{ Torr}$ ) or less

High-frequency electric power : 400 W

Ar gas pressure:  $8.0 \times 10^{-1}$  to  $1.1 \text{ Pa}$  (6 to  $8 \times 10^{-3} \text{ Torr}$ )

Distance between electrodes: 72 mm

Table 1

| No. | Film composition                                  | Bs(T) | Hc(Oe) | $\rho(\mu\Omega \cdot \text{cm})$ | $\mu_{\text{eff}} (10\text{MHz})$ |
|-----|---|-------|--------|-----------------------------------|-----------------------------------|
| 1   | $\text{Fe}_{54.9}\text{Hf}_{11.0}\text{O}_{34.1}$ | 1.2   | 0.8    | 803                               | 2199                              |
| 2   | $\text{Fe}_{51.5}\text{Hf}_{12.2}\text{O}_{36.3}$ | 1.1   | 1.2    | 1100                              | 1130                              |
|     |   |       |        |                                   |                                   |
| 4   | $\text{Fe}_{46.8}\text{Hf}_{18.2}\text{O}_{35.6}$ | 0.7   | 0.7    | 133709                            | 100                               |
| 5   | $\text{Fe}_{69.8}\text{Zr}_{6.5}\text{O}_{23.7}$  | 1.5   | 0.56   | 400                               | 2050                              |
| 6   | $\text{Fe}_{65.3}\text{Zr}_{8.9}\text{O}_{25.8}$  | 1.3   | 0.91   | 460                               | 1030                              |
| 7   | $\text{Fe}_{64.4}\text{Nb}_{12.2}\text{O}_{23.4}$ | 1.3   | 0.66   | 420                               | 1600                              |
| 8   | $\text{Fe}_{59.4}\text{Ta}_{15.3}\text{O}_{25.3}$ | 1.1   | 1.63   | 880                               | 580                               |
| 9   | $\text{Fe}_{51.5}\text{Ti}_{17.5}\text{O}_{31.0}$ | 1.1   | 1.38   | 750                               | 420                               |

Table 1 (continued)

| No.  | Film composition                                  | Bs(T) | Hc(Oe) | $\rho(\mu\Omega \cdot \text{cm})$ | $\mu_{\text{eff}} (10\text{MHz})$ |
|--|---|-------|--------|-----------------------------------|-----------------------------------|
| 10   | $\text{Fe}_{55.8}\text{V}_{13.2}\text{O}_{31.0}$  | 1.2   | 1.5    | 560                               | 550                               |
| 11   | $\text{Fe}_{58.7}\text{W}_{15.8}\text{O}_{25.5}$  | 1.2   | 2.25   | 670                               | 400                               |
| 12   | $\text{Fe}_{61.6}\text{Y}_{5.3}\text{O}_{33.1}$   | 1.4   | 1.31   | 420                               | 780                               |
| 13   | $\text{Fe}_{63.2}\text{Ce}_{7.8}\text{O}_{29.0}$  | 1.1   | 1.88   | 580                               | 640                               |
| 14   | $\text{Fe}_{69.8}\text{Sm}_{11.0}\text{O}_{19.2}$ | 1.3   | 2.0    | 500                               | 400                               |
| 15   | $\text{Fe}_{68.5}\text{Ho}_{11.5}\text{O}_{20.0}$ | 1.1   | 1.2    | 800                               | 500                               |
| 16   | $\text{Fe}_{64.2}\text{Gd}_{11.5}\text{O}_{24.3}$ | 1.2   | 3.4    | 840                               | 350                               |
| 17   | $\text{Fe}_{61.8}\text{Tb}_{10.8}\text{O}_{27.4}$ | 1.1   | 2.3    | 750                               | 450                               |
| 18   | $\text{Fe}_{62.5}\text{Dy}_{9.5}\text{O}_{28}$    | 1.1   | 4.0    | 680                               | 530                               |
| 19   | $\text{Fe}_{59.8}\text{Er}_{13.5}\text{O}_{26.7}$ | 1.0   | 3.7    | 580                               | 380                               |
| 20   | $\text{Fe}_{91.7}\text{Hf}_{4.1}\text{O}_{4.2}$   |       |        | 217.2                             |                                   |
| 21   | $\text{Fe}_{94.6}\text{Hf}_{2.0}\text{O}_{3.4}$   |       |        | 315.3                             |                                   |
| 22   | $\text{Fe}_{95.9}\text{Hf}_{1.0}\text{O}_{3.1}$   |       |        | 218.0                             |                                   |
| 23   | $\text{Fe}_{91.1}\text{Hf}_{2.1}\text{O}_{6.8}$   |       |        | 294.1                             |                                   |
| 24   | $\text{Fe}_{93.5}\text{Hf}_{1.0}\text{O}_{5.5}$   |       |        | 215.3                             |                                   |
| 25   | $\text{Fe}_{87.2}\text{Hf}_{3.5}\text{O}_{9.3}$   |       |        | 315.0                             |                                   |
| 26   | $\text{Fe}_{88.8}\text{Hf}_{2.1}\text{O}_{9.1}$   |       |        | 338.3                             |                                   |
| 27   | $\text{Fe}_{88.4}\text{Hf}_{2.1}\text{O}_{9.5}$   |       |        | 250.2                             |                                   |
| Films of composition nos. 20-27 in Table 1 are examples for comparison |   |       |        |                                   |                                   |

[0042] As shown in Table 1, a thin magnetic film No. 4 having a composition of  $\text{Fe}_{46.2}\text{Hf}_{18.2}\text{O}_{35.6}$  is able to have a specific resistance  $\rho$  of 133709  $\mu\Omega\cdot\text{cm}$ , which is the specific resistance after annealing. Before annealing, a specific resistance as high as 194000  $\mu\Omega\cdot\text{cm}$  can be attained. In addition, a specific resistance of about 215 to 1767  $\mu\Omega\cdot\text{cm}$  can be attained easily in a FeHfO, FeZrO, FeNbO, FeTaO, FeTiO, FeVO, FeWO, FeYO, FeCeO, FeSmO, FeHoO, FeGdO, FeTbO, FeDyO or FeErO base composition by adjusting the compounding ratio of each component of the above composition.

[0043] Each of the samples shown in Tables 2 and 3 was obtained by preparing an alloy target composed of  $\text{Fe}_{87}\text{Hf}_{13}$ , adjusting the amount of nitrogen contained in an Ar gas, which was used as a carrier gas, to fall within a range of 5 to 80% and conducting high-frequency sputtering under the conditions of a gas pressure of 0.6 Pa and input voltage of 200 W. The compounding ratio of Fe and Hf was adjusted by an increase or decrease in the number of the chips of Hf. The soft magnetic alloy thin film so obtained was annealed at 400°C for 3 hours in a magnetic field of 2 kOe. Then, a saturation magnetic flux density (Bs:T), coercive force (Hc:Oe), a ratio of the saturation magnetic field to anisotropic magnetic field (Hk:Oe) when a magnetic field was applied to the hard axis direction, a magnetic permeability ( $\mu$ : 10 MHz), a magnetostriction ( $\lambda_s$ :  $\times 10^{-6}$ ) and specific resistance ( $\rho$ :  $\Omega\text{cm}$ ) of the sample so obtained by annealing were measured. The results are shown in Tables 2 and 3.

Table 2

| Sample No. |   |                 | Bs(T) | Hc(Oe) | Hk(Oe) |
|------------|---|-----------------|-------|--------|--------|
| 1          | $\text{Fe}_{77.6}\text{Hf}_{13.6}\text{N}_{8.8}$  | As deposited    | 6.2   | 1.68   | 3.52   |
|            |   | After annealing | 11.3  | 0.31   | 2.29   |
| 2          | $\text{Fe}_{71.5}\text{Hf}_{12.4}\text{N}_{16.1}$ | As deposited    | 9.8   | -      | -      |
|            |   | After annealing | 11.9  | -      | 4.24   |

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Table 2 (continued)

| Sample No. |   |                 | Bs(T) | Hc(Oe) | Hk(Oe) |
|------------|---|-----------------|-------|--------|--------|
| 3          | $\text{Fe}_{66.7}\text{Hf}_{11.8}\text{N}_{21.5}$ | As deposited    | 6.5   | -      | 0.8    |
|            |   | After annealing | 7.8   | 0.73   | 1.46   |
| 4          | $\text{Fe}_{74.3}\text{Hf}_{13.6}\text{N}_{12.1}$ | As deposited    | 14.9  | 0.3    | 1.64   |
|            |   | After annealing | 15.0  | 0.4    | 2.64   |
|            |   |                 |       |        |        |
| 6          | $\text{Fe}_{69.1}\text{Hf}_{11.8}\text{N}_{19.1}$ | As deposited    | 11.7  | 0.68   | 4.98   |
|            |   | After annealing | 11.6  | 0.78   | 6.70   |
| 7          | $\text{Fe}_{75.3}\text{Hf}_{14.7}\text{N}_{10}$   | As deposited    | 3.8   | -      | -      |
|            |   | After annealing | 8.8   | 0.32   | 1.34   |
| 8          | $\text{Fe}_{64.8}\text{Hf}_{13.2}\text{N}_{22}$   | As deposited    | 5.6   | 0.63   | 1.94   |
|            |   | After annealing | 6.8   | 0.37   | 2.32   |
| 9          | $\text{Fe}_{69.2}\text{Hf}_{13.9}\text{N}_{16.9}$ | As deposited    | 9.0   | 0.21   | 0.66   |
|            |   | After annealing | 11.0  | 0.55   | 5.58   |
| 10         | $\text{Fe}_{67}\text{Hf}_{14}\text{N}_{19}$       | As deposited    | 11.8  | 0.70   | 3.44   |
|            |   | After annealing | 11.7  | 0.66   | 5.68   |
| 11         | $\text{Fe}_{64.8}\text{Hf}_{14.1}\text{N}_{21.1}$ | As deposited    | 5.2   | 0.31   | 0.58   |
|            |   | After annealing | 6.5   | 0.38   | 1.8    |
| 12         | $\text{Fe}_{61.5}\text{Hf}_{13.4}\text{N}_{25.1}$ | As deposited    | 0.27  | -      | -      |
|            |   | After annealing | -     | -      | -      |

Table 3

| Sample No. |                 | $\mu$ (10MHz) | $\lambda s (\times 10^{-6})$ | $\rho$ ( $\mu \Omega \text{cm}$ ) |
|------------|-----------------|---------------|------------------------------|-----------------------------------|
| 1          | As deposited    | 38            | 0.93                         | 193.6                             |
|            | After annealing | 2518          | 2.25                         | 150.8                             |
| 2          | As deposited    | 252           | 6.97                         | 278.6                             |
|            | After annealing | 1174          | 8.62                         | 251.9                             |
| 3          | As deposited    | 253           | 4.06                         | 312.7                             |
|            | After annealing | 1274          | 5.55                         | 343.7                             |
| 4          | As deposited    | 1192          | 3.76                         | 140.9                             |
|            | After annealing | 4128          | 3.57                         | 132.5                             |
| 5          | As deposited    | 750           | 6.86                         | 192.8                             |
|            | After annealing | 2114          | 7.00                         | 186.5                             |
| 6          | As deposited    | 734           | 10.02                        | 293.3                             |
|            | After annealing | 1152          | 9.47                         | 267.9                             |
| 7          | As deposited    | 6.70          | -0.06                        | 235.0                             |
|            | After annealing | 948           | 1.36                         | 184.4                             |
| 8          | As deposited    | 352           | 7.83                         | 263.3                             |
|            | After annealing | 1608          | 4.23                         | 376.2                             |

Table 3 (continued)

| Sample No. |                 | $\mu$ (10MHz) | $\lambda s (\times 10^{-6})$ | $\rho (\mu \Omega \text{cm})$ |
|------------|-----------------|---------------|------------------------------|-------------------------------|
| 9          | As deposited    | 128           | 2.44                         | 453.6                         |
|            | After annealing | 1522          | 7.77                         | 291.4                         |
| 10         | As deposited    | 343           | 8.83                         | 292.0                         |
|            | After annealing | 1139          | 9.72                         | 286.3                         |
| 11         | As deposited    | 146           | 3.33                         | 359.5                         |
|            | After annealing | 2067          | 3.81                         | 385.8                         |
| 12         | As deposited    | -             | -                            | 422.4                         |
|            | After annealing | -             | -                            | 376.9                         |

**[0044]** Each sample shown in Tables 1 and 2 exhibited an excellent saturation magnetic flux density, coercive force, magnetic permeability and magnetostriction and exhibited a specific resistance as high as about 200 to 400  $\Omega \text{cm}$ . Incidentally, when the value of the anisotropic magnetic field is small, the magnetic permeability at a low frequency region increases but tends to show a marked decrease in the high frequency region, while when the value of the anisotropic magnetic field is large, the magnetic permeability not so large in the low frequency region can be maintained even in the high frequency region, which suggests an excellent magnetic permeability in a high frequency region.

**[0045]** In the FeMO base thin magnetic film, as disclosed in Table 1, a saturation magnetic flux density of 1.0 to 1.5 T (10 to 15 kG) can be attained, while in the FeMN base thin magnetic film, that exceeding 1 T (10 kG) can easily be attained. In either of the films, it is possible to attain a saturation magnetic flux density of 10 kG or higher by far higher than that, 5 kG, of the ferrite or the like.

#### Examples

**[0046]** A thin magnetic element sample was fabricated by forming thin magnetic films each having the composition of  $\text{Fe}_{55}\text{Hf}_{11}\text{O}_{34}$  and a thickness of 3  $\mu\text{m}$  on two 12 cm x 12 cm quadrature substrates made of a high polymer film or ceramic; forming, on the thin magnetic films, square spiral coils made of copper as illustrated in FIG. 2 through 17- $\mu\text{m}$  thick insulation films composed of  $\text{SiO}_2$  (or high polymer); and then, as illustrated in FIG. 1, disposing the resulting substrates, as illustrated in FIG. 1, on both sides of an insulation layer formed of  $\text{SiO}_2$  or a high polymer, respectively. The spiral coil employed has an overall width D of 10 mm and 9 turns.

**[0047]** FIG. 3 shows the measuring results of the dependence of the thickness of the magnetic film on the upstream figure of merit Q at the frequency of 10 MHz when the width of the coil conductor is 0.4 mm, the distance between coil conductors is 0.5 mm and the thickness of the coil conductor is t. As is apparent from the results shown in FIG. 3, when the thickness of the magnetic layer falls within a range of 0.5  $\mu\text{m}$  or greater but 8  $\mu\text{m}$  or smaller, the upstream figure of merit Q not smaller than 1.5 can be attained and moreover, when the thickness of the magnetic layer falls within a range of 1  $\mu\text{m}$  or greater but 6  $\mu\text{m}$  or smaller, the upstream figure of merit Q not smaller than 2 can be attained.

**[0048]** FIG. 4 illustrates the variations of the inductance measure at 10 MHz as a function of the ratio of the coil conductor width represented by the formula  $a/(a+b)$ , when the magnetic layer thickness is adjusted to 3  $\mu\text{m}$  and the distance between the adjacent coil conductors 6,6 is designated as b. FIG. 5 illustrates the results of the variations of an equivalent resistance measured at 10 MHz as a function of a ratio of a coil conductor width, which is represented by  $w/(w+b)$ , of a thin magnetic element having the similar composition. FIG. 6 illustrates the variations of the figure of merit Q as measured at 10 MHz as a function of the ratio of the coil conductor width.

**[0049]** From the results shown in FIGS. 4, 5 and 6, it can be understood that when the ratio of the coil conductor width is at least 0.2, the equivalent resistance shows a drastic reduction and becomes a good value and besides, a high figure of merit Q can be obtained. In FIG. 4, the inductance showed a slight lowering tendency with a rise in the coil conductor width, which is presumed to be caused by the disturbance of the magnetic flux by the coil conductor. In FIG. 5, the equivalent resistance shows an increase when the coil conductor width is narrow, which owes to the small cross-sectional area of the coil conductor itself. The wider the coil conductor width, the higher the value of Q, which results from the properties of the equivalent resistance. It is apparent that the figure of merit is within a preferred range when the ratio of the coil conductor width is at least one 0.2.

**[0050]** FIG. 7 shows the results of a temperature rise, as measured by a thermocouple, which appeared at the time of the energization test conducted on a plural number of coil samples which were formed on a polyimide film of 25  $\mu\text{m}$  thick to have a spiral shape as illustrated in FIG. 2 and have a copper-made coil conductor having a thickness of 35



μm and width of 0.15 mm, 0.2 mm, 0.3 mm, 0.4 mm and 0.5 mm, respectively. FIG. 8 shows the results of the similar test when the copper-made coil conductor had a thickness of 70 μm.

[0051] When the temperature does not exceed 50°C in the results shown in FIGS. 7 and 8, the resulting coil conductor can be provided for a practical use and the current to be applied within a range of about 0.5 to 1.0A is practical.

[0052] In consideration of the above results, it is possible to select a coil conductor width a from a range of 0.3 mm to 1.0 mm in the case of the copper-made conductor coil having a thickness of 35 μm, while it is possible to select a coil conductor width a from a range of 0.2 mm to 1.00 mm in the case of the copper-made conductor coil having a thickness of 70 μm. Accordingly, it can be understood that the aspect ratio indicated by t/w preferably falls within a range of 0.035 to 0.12 in the case of the copper-made conductor coil of 35 μm thick and a range of 0.07 to 0.35 in the case of the conductor coil of 70 μm thick. In either case, generation of heat can be suppressed if the aspect ratio falls within a range of 0.035 to 0.35, more preferably in a range of 0.07 to 0.12. Incidentally, the coil conductor width exceeding 1.0 mm tends to cause short-cut of the adjacent conductor coil, which disturbs the size reduction of the element. The coil conductor width a is therefore adjusted to be 1.0 mm or smaller. Also in the case of a zig-zag type coil, it is preferred to adjust the coil conductor width to 1.0 mm or smaller, because magnetic fluxes of the adjacent conductor coils, which fluxes are opposite to each other, interfere each other.

## Claims

1. A thin magnetic element comprising a coil pattern formed on at least one side of a substrate and a thin magnetic film formed on the coil pattern, wherein:

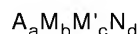
said thin magnetic film is formed to a thickness of 0.5 μm or greater but 8 μm or smaller;

and at least one of the following conditions is satisfied;

assuming that the thickness and width of one winding of the coil are "t" and "w", respectively, an aspect ratio t/w of the coil satisfies the relationship of  $0.035 \leq t/w \leq 0.35$ ; and

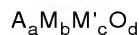
assuming that the width of one winding of the coil constituting the coil pattern is w and the distance between one whole coil and the next coil in the coil pattern is "b", the relationship of  $0.2 < w/(w+b)$  is satisfied, wherein; the thin magnetic film comprises a fine crystalline phase which is composed mainly of at least one element selected from the group consisting of Fe, Co and Ni and has an average grain size of 30 nm; and an amorphous phase which is composed mainly of a compound formed of at least one element selected from the group consisting of lanthanide type rare earth elements (at least one of La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm and Lu), Ti, Zr, Hf, Ta, Nb, Mo and W and O or N.

2. A thin magnetic element according to Claim 1, wherein the thin magnetic film is represented by the composition formula:



wherein A represents at least one element selected from the group consisting of Fe, Co and Ni, M represents at least one element selected from the group consisting of lanthanide type rare earth elements (at least one of La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm and Lu), Ti, Zr, Hf, V, Nb, Ta and W, M' represents at least one element selected from the group consisting of Al, Si, Cr, Pt, Ru, Rh, Pd and Ir; and N is the element N; and a, b, c and d which show compounding ratios satisfy the following relationships:  $20 \leq a \leq 80$ ,  $5 \leq b \leq 30$ ,  $0 \leq c \leq 10$  and  $15 \leq d \leq 55$  each in atomic %.

3. A thin magnetic element according to Claim 1, wherein the thin magnetic film is represented by the composition formula:



wherein A represents at least one element selected from the group consisting of Fe, Co and Ni, M represents at least one element selected from the group consisting of lanthanide type rare earth elements (at least one of La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm and Lu), Ti, Zr, Hf, V, Nb, Ta and W, M' represents at least one element selected from the group consisting of Al, Si, Cr, Pt, Ru, Rh, Pd and Ir; and O is the element O; and a, b, c and d which show compounding ratios satisfy the following relationships:  $20 \leq a \leq 70$ ,  $5 \leq b \leq 30$ ,  $0 \leq c \leq 10$  and

$15 \leq d \leq 55$  each in atomic %.

4. A transformer, comprising coil patterns formed on both sides of a substrate and thin magnetic films formed on the coil patterns, wherein:

each of said thin magnetic films is formed to a thickness of  $0.5 \mu\text{m}$  or greater but  $8 \mu\text{m}$  or smaller; and at least one of the following conditions is satisfied:

assuming that the thickness and the width of one winding of the coil constituting the coil pattern are  $t$  and  $w$ , respectively, an aspect ratio  $t/w$  of the coil satisfies the relationship of  $0.035 \leq t/w \leq 0.35$ ; and assuming that the width of one winding of the coil constituting the coil pattern is  $w$  and the distance between one whole coil and the next in the coil pattern is  $b$ , the relationship of  $0.2 < w/(w+b)$  is satisfied, wherein; the thin magnetic film comprises a fine crystalline phase which is composed mainly of at least one element selected from the group consisting of Fe, Co and Ni and has an average grain size of  $30 \text{ nm}$  and an amorphous phase which is composed mainly of a compound formed of at least one element M selected from the group consisting of lanthanide type rare earth elements (at least one of La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm and Lu), Ti, Zr, Hf, Ta, Nb, Mo and W and O or N.

5. A transformer according to Claim 3, which is represented by the composition formula  $A_a M_b M'_c N_d$  wherein A represents at least one element selected from the group consisting of Fe, Co and Ni, M represents at least one element selected from the group consisting of lanthanide type rare earth elements (at least one of La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm and Lu) and Ti, Zr, Hf, V, Nb, Ta and W, M' represents at least one element selected from the group consisting of Al, Si, Cr, Pt, Ru, Rh, Pd and Ir; and N is the element N; and in the above composition formula,  $a$ ,  $b$ ,  $c$  and  $d$  which show the compounding ratios satisfy the following relationships:  $20 \leq a \leq 80$ ,  $5 \leq b \leq 30$ ,  $0 \leq c \leq 10$  and  $15 \leq d \leq 55$  each in atomic %.

6. A transformer according to Claim 3, which is represented by the composition formula  $A_a M_b M'_c O_d$  wherein A represents at least one element selected from the group consisting of Fe, Co and Ni, M represents at least one element selected from the group consisting of lanthanide type rare earth elements (at least one of La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm and Lu) and Ti, Zr, Hf, V, Nb, Ta and W, M' represents at least one element selected from the group consisting of Al, Si, Cr, Pt, Ru, Rh, Pd and Ir; and O is the element O; and in the above composition formula,  $a$ ,  $b$ ,  $c$  and  $d$  which show the compounding ratios satisfy the following relationships:  $20 \leq a \leq 70$ ,  $5 \leq b \leq 30$ ,  $0 \leq c \leq 10$  and  $15 \leq d \leq 55$  each in atomic %.

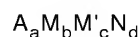
## Patentansprüche

1. Dünnes magnetisches Element mit einem auf wenigstens einer Seite eines Substrats geformten Spulenmuster und einem auf dem Spulenmuster geformten dünnen magnetischen Film, wobei:

der dünne magnetische Film mit einer Dicke von  $0,5 \mu\text{m}$  oder größer, jedoch  $8 \mu\text{m}$  oder kleiner geformt ist; und wenigstens eine der folgenden Bedingungen erfüllt ist: angenommen, dass die Dicke und Breite einer Windung der Spule " $t$ " bzw. " $w$ " sind, dann erfüllt ein Längenverhältnis  $t/w$  der Spule die Bedingung  $0,035 \leq t/w \leq 0,35$ ; und angenommen, dass die Breite einer Windung der das Spulenmuster bildenden Spule  $w$  und der Abstand zwischen einer ganzen Spule und der nächsten Spule in dem Spulenmuster " $b$ " ist, dann ist die Bedingung  $0,2 < w/(w+b)$  erfüllt, wobei

der dünne magnetische Film eine feine kristalline Phase, die hauptsächlich aus wenigstens einem Element besteht, das aus der Gruppe, bestehend aus Fe, Co und Ni gewählt ist, und eine mittlere Korngröße von  $30 \text{ nm}$  hat, und eine amorphe Phase, die hauptsächlich aus einer Verbindung besteht, die aus wenigstens einem Element geformt ist, das aus der Gruppe gewählt ist, die aus den Elementen der Seltenen Erden vom Lanthanidentyp (wenigstens eines aus La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm und Lu), Ti, Zr, Hf, Ta, Nb, Mo und W und O oder N besteht, umfasst.

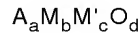
2. Dünnes magnetisches Element nach Anspruch 1, wobei der dünne magnetische Film durch die Zusammensetzungsformel:



dargestellt ist,

worin A wenigstens ein Element darstellt, das aus der Gruppe bestehend aus Fe, Co und Ni gewählt ist, M wenigstens ein Element darstellt, das aus der Gruppe bestehend aus den Elementen der Seltenen Erden vom Lanthanid-Typ (wenigstens eines aus La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm und Lu), Ti, Zr, Hf, V, Nb, Ta, und W, gewählt ist, und M' wenigstens ein Element darstellt, das aus der Gruppe bestehend aus Al, Si, Cr, Pt, Ru, Rh, Pd und Ir gewählt ist; und N das Element N ist; und a, b, c und d, welche die Zusammensetzungsverhältnisse zeigen, den folgenden Beziehungen genügen:  $20 \leq a \leq 80$ ;  $5 \leq b \leq 30$ ,  $0 \leq c \leq 10$  und  $15 \leq d \leq 55$ , jeweils in Atom-%.

3. Dünnes magnetisches Element nach Anspruch 1, wobei der dünne magnetische Film durch die Zusammensetzungsformel:



dargestellt ist,

worin A wenigstens ein Element darstellt, das aus der Gruppe bestehend aus Fe, Co und Ni gewählt ist, M wenigstens ein Element darstellt, das aus der Gruppe bestehend aus den Elementen der Seltenen Erden vom Lanthanid-Typ (wenigstens eines aus La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm und Lu), Ti, Zr, Hf, V, Nb, Ta, und W, gewählt ist, und M' wenigstens ein Element darstellt, das aus der Gruppe bestehend aus Al, Si, Cr, Pt, Ru, Rh, Pd und Ir gewählt ist; und O das Element O ist; und a, b, c und d, welche die Zusammensetzungsverhältnisse zeigen, den folgenden Beziehungen genügen:  $20 \leq a \leq 70$ ;  $5 \leq b \leq 30$ ,  $0 \leq c \leq 10$  und  $15 \leq d \leq 55$ , jeweils in Atom-%.

4. Transformator mit auf beiden Seiten eines Substrats geformten Spulenmustern und auf den Spulenmustern geformten dünnen magnetischen Filmen, wobei:

jeder der dünnen magnetischen Filme mit einer Dicke von 0,5 µm oder größer, jedoch 8 µm oder kleiner geformt ist; und wenigstens eine der folgenden Bedingungen erfüllt ist:

angenommen, dass die Dicke und Breite einer Windung der das Spulenmuster bildenden Spule t bzw. w sind, dann erfüllt ein Längenverhältnis t/w der Spule die Bedingung  $0,035 \leq t/w \leq 0,35$ ; und angenommen, dass die Breite einer Windung der das Spulenmuster bildenden Spule w und der Abstand zwischen einer ganzen Spule und der nächsten Spule in dem Spulenmuster b ist, dann ist die Bedingung  $0,2 < w/(w+b)$  erfüllt, wobei der dünne magnetische Film eine feine kristalline Phase, die hauptsächlich aus wenigstens einem Element besteht, das aus der Gruppe, bestehend aus Fe, Co und Ni gewählt ist, und eine mittlere Korngröße von 30 nm hat, und eine amorphe Phase, die hauptsächlich aus einer Verbindung besteht, die aus wenigstens einem Element geformt ist, das aus der Gruppe gewählt ist, die aus den Elementen der Seltenen Erden vom Lanthanidentyp (wenigstens eines aus La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm und Lu), Ti, Zr, Hf, Ta, Nb, Mo und W und O oder N besteht, umfasst.

5. Transformator nach Anspruch 3, welcher durch die Zusammensetzungsformel  $A_a M_b M'_c N_d$  dargestellt ist, worin A wenigstens ein Element darstellt, das aus der Gruppe bestehend aus Fe, Co und Ni gewählt ist, M wenigstens ein Element darstellt, das aus der Gruppe bestehend aus den Elementen der Seltenen Erden vom Lanthanid-Typ (wenigstens eines aus La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm und Lu), Ti, Zr, Hf, V, Nb, Ta, und W, gewählt ist, und M' wenigstens ein Element darstellt, das aus der Gruppe bestehend aus Al, Si, Cr, Pt, Ru, Rh, Pd und Ir gewählt ist; und N das Element N ist; und in der obigen Zusammensetzungformel a, b, c und d, welche die Zusammensetzungsverhältnisse zeigen, den folgenden Beziehungen genügen:  $20 \leq a \leq 80$ ;  $5 \leq b \leq 30$ ,  $0 \leq c \leq 10$  und  $15 \leq d \leq 55$ , jeweils in Atom-%.

6. Transformator nach Anspruch 3, welcher durch die Zusammensetzungsformel  $A_a M_b M'_c O_d$  dargestellt ist, worin A wenigstens ein Element darstellt, das aus der Gruppe bestehend aus Fe, Co und Ni gewählt ist, M wenigstens ein Element darstellt, das aus der Gruppe bestehend aus den Elementen der Seltenen Erden vom Lanthanid-Typ (wenigstens eines aus La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm und Lu), Ti, Zr, Hf, V, Nb, Ta, und W, gewählt ist, und M' wenigstens ein Element darstellt, das aus der Gruppe bestehend aus Al, Si, Cr, Pt, Ru, Rh, Pd und Ir gewählt ist; und O das Element O ist; und in der obigen Zusammensetzungformel a, b, c und d, welche die Zusammensetzungsverhältnisse zeigen, den folgenden Beziehungen genügen:  $20 \leq a \leq 70$ ;  $5 \leq b \leq 30$ ,  $0 \leq c \leq 10$  und  $15 \leq d \leq 55$ , jeweils in Atom-%.

## Revendications

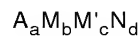
1. Élément magnétique mince comprenant un motif d'enroulement formé sur au moins une face d'un substrat, et un mince film magnétique formé sur ledit motif d'enroulement, dans lequel :

ledit mince film magnétique est formé à une épaisseur de 0,5  $\mu\text{m}$  ou plus, mais de 8  $\mu\text{m}$  ou moins, et au moins l'une des conditions suivantes est satisfaite :

en supposant que l'épaisseur et la largeur d'une spire de l'enroulement soient "t" et "w", respectivement, le rapport de forme t/w de l'enroulement satisfait la relation  $0,035 \leq t/w \leq 0,35$ , et en supposant que la largeur d'une spire de l'enroulement constituant le motif de l'enroulement soit w et que la distance entre l'enroulement entier et l'enroulement suivant dans le motif d'enroulement soit "b", la relation  $0,2 < w/(w+b)$  est satisfaite ; élément dans lequel,

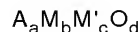
le mince film magnétique comprend une phase cristalline fine qui est principalement composée d'au moins un élément choisi parmi le groupe constitué de Fe, Co et Ni, et présente une taille moyenne de grain de 30 nm, et d'une phase amorphe qui est composée principalement d'un composé formé d'au moins un élément choisi parmi le groupe constitué des éléments de terres rares de type lanthanide (au moins l'un parmi La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm et Lu), de Ti, Zr, Hf, Ta, Nb, Mo et de W et de O ou N.

2. Élément magnétique mince selon la revendication 1, dans lequel le mince film magnétique est représenté par la formule de composition :



dans laquelle A représente au moins un élément choisi parmi le groupe constitué de Fe, Co et Ni, M représente au moins un élément choisi parmi le groupe constitué des éléments de terres rares de type lanthanide (au moins l'un parmi La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm et Lu), de Ti, Zr, Hf, V, Nb, Ta et W, M' représente au moins un élément choisi parmi le groupe constitué de Al, Si, Cr, Pt, Ru, Rh, Pd et Ir, et N est l'élément N, et dans laquelle a, b, c et d, qui correspondent à des rapports de composition, satisfont les relations suivantes :  $20 \leq a \leq 80$ ,  $5 \leq b \leq 30$ ,  $0 \leq c \leq 10$  et  $15 \leq d \leq 55$ , chacun en % atomique.

3. Élément magnétique mince selon la revendication 1, dans lequel le mince film magnétique est représenté par la formule de composition :



dans laquelle A représente au moins un élément choisi parmi le groupe constitué de Fe, Co et Ni, M représente au moins un élément choisi parmi le groupe constitué des éléments de terres rares de type lanthanide (au moins l'un parmi La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm et Lu), de Ti, Zr, Hf, V, Nb, Ta et W, M' représente au moins un élément choisi parmi le groupe constitué de Al, Si, Cr, Pt, Ru, Rh, Pd et Ir, et O est l'élément O, et dans laquelle a, b, c et d, qui correspondent à des rapports de composition, satisfont les relations suivantes :  $20 \leq a \leq 70$ ,  $5 \leq b \leq 30$ ,  $0 \leq c \leq 10$  et  $15 \leq d \leq 55$ , chacun en % atomique.

4. Transformateur comprenant des motifs d'enroulement formés sur les deux faces d'un substrat et des minces films magnétiques formés sur les motifs d'enroulement, dans lequel:

chacun desdits minces films magnétiques est formé jusqu'à une épaisseur de 0,5  $\mu\text{m}$  ou plus, mais de 8  $\mu\text{m}$  ou moins, et au moins l'une des conditions suivantes est satisfaite :

en supposant que l'épaisseur et la largeur d'une spire de l'enroulement constituant le motif d'enroulement soient "t" et "w", respectivement, le rapport de forme t/w de l'enroulement satisfait la relation  $0,035 \leq t/w \leq 0,35$ , et

en supposant que la largeur d'une spire de l'enroulement constituant le motif d'enroulement soit w et que la distance entre l'enroulement entier et l'enroulement suivant dans le motif d'enroulement soit "b", la relation  $0,2 < w/(w+b)$  est satisfaite ; élément dans lequel,

le mince film magnétique comprend une phase cristalline fine qui est composée principalement d'au moins un élément choisi parmi le groupe constitué de Fe, Co et Ni, et présente une taille moyenne de grain de 30 nm, et d'une phase amorphe qui est composée principalement d'un composé formé d'au moins un élément M choisi parmi le groupe constitué des éléments de terres rares de type lanthanide (au moins l'un parmi La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm et Lu), de Ti, Zr, Hf, Ta, Nb, Mo et de W et de O ou N.

5. Transformateur selon la revendication 4, dans lequel le mince film magnétique est représenté par la formule de composition  $A_a M_b M'_c N_d$ , où A représente au moins un élément choisi parmi le groupe constitué de Fe, Co et Ni, M représente au moins un élément choisi parmi le groupe constitué des éléments de terres rares de type lanthanide (au moins l'un parmi La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm et Lu), de Ti, Zr, Hf, V, Nb, Ta et W, M' représente au moins un élément choisi parmi le groupe constitué de Al, Si, Cr, Pt, Ru, Rh, Pd et Ir, et N est l'élément N, et dans la formule de composition ci-dessus, a, b, c et d, qui correspondent à des rapports de composition, satisfont les relations suivantes :  $20 \leq a \leq 80$ ,  $5 \leq b \leq 30$ ,  $0 \leq c \leq 10$  et  $15 \leq d \leq 55$ , chacun en % atomique.

6. Transformateur selon la revendication 4, dans lequel le mince film magnétique est représenté par la formule de composition  $A_a M_b M'_c O_d$ , où A représente au moins un élément choisi parmi le groupe constitué de Fe, Co et Ni, M représente au moins un élément choisi parmi le groupe constitué des éléments de terres rares de type lanthanide (au moins l'un parmi La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm et Lu), et de Ti, Zr, Hf, V, Nb, Ta et W, M' représente au moins un élément choisi parmi le groupe constitué de Al, Si, Cr, Pt, Ru, Rh, Pd et Ir, et O est l'élément O, et dans la formule de composition ci-dessus, a, b, c et d, qui correspondent à des rapports de composition, satisfont les relations suivantes :  $20 \leq a \leq 70$ ,  $5 \leq b \leq 30$ ,  $0 \leq c \leq 10$  et  $15 \leq d \leq 55$ , chacun en % atomique.

FIG. 1

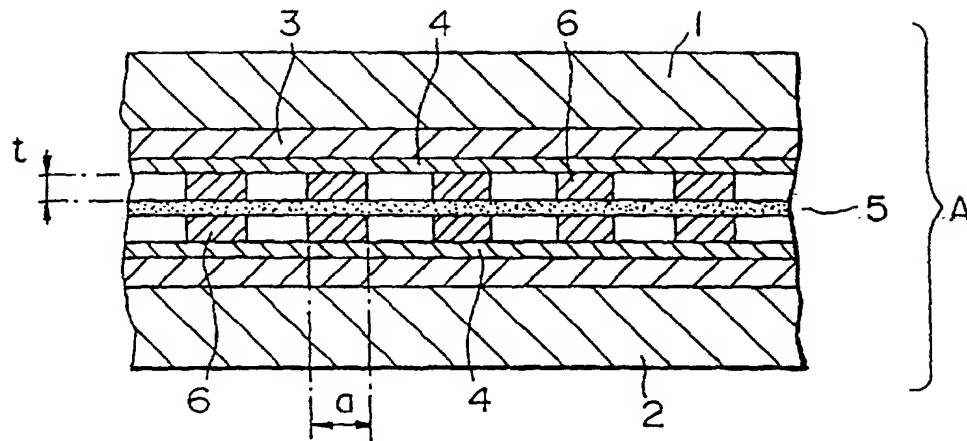


FIG. 2

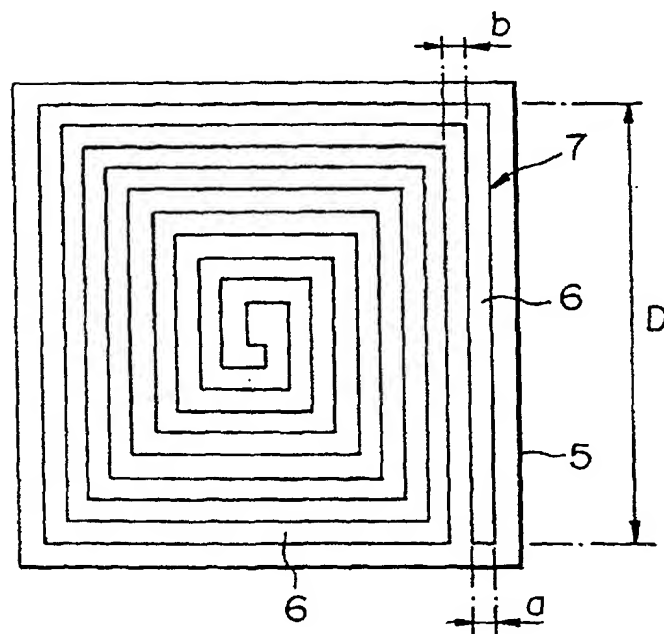


FIG. 3

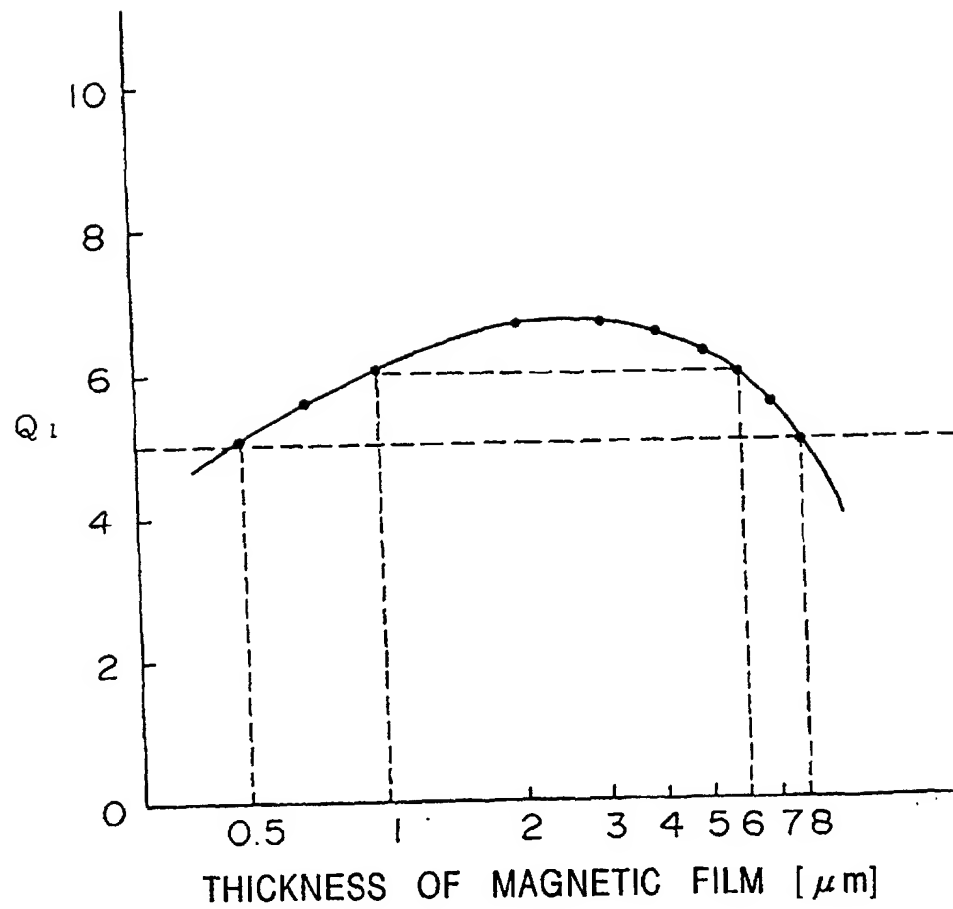


FIG. 4

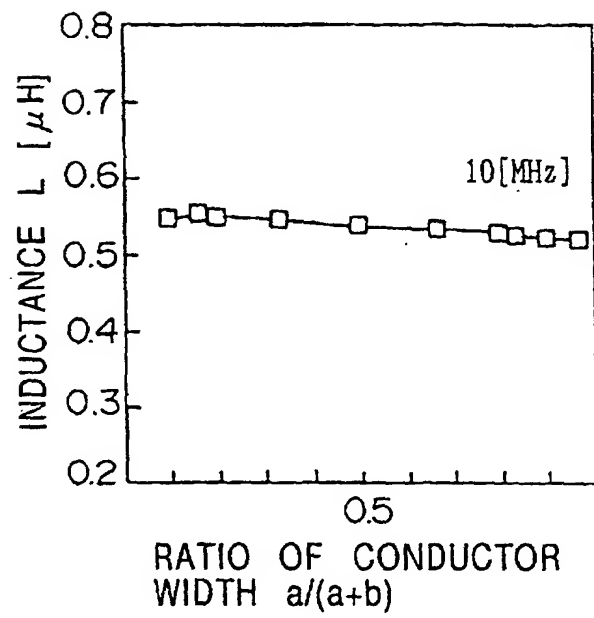


FIG. 5

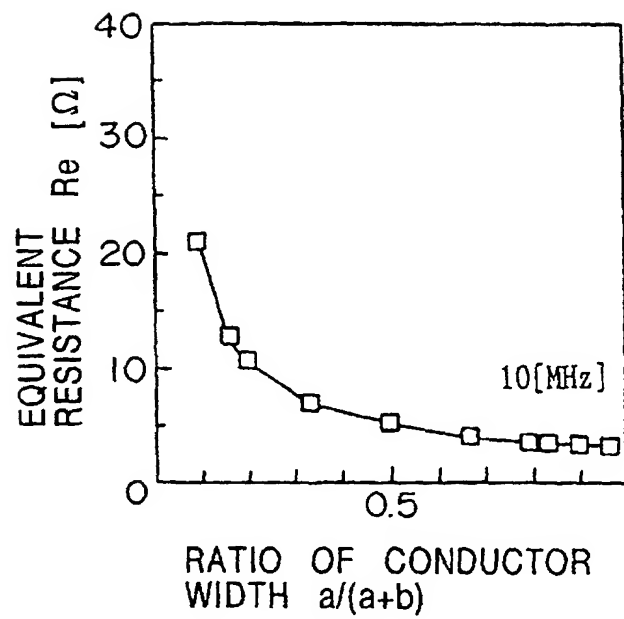




FIG. 6

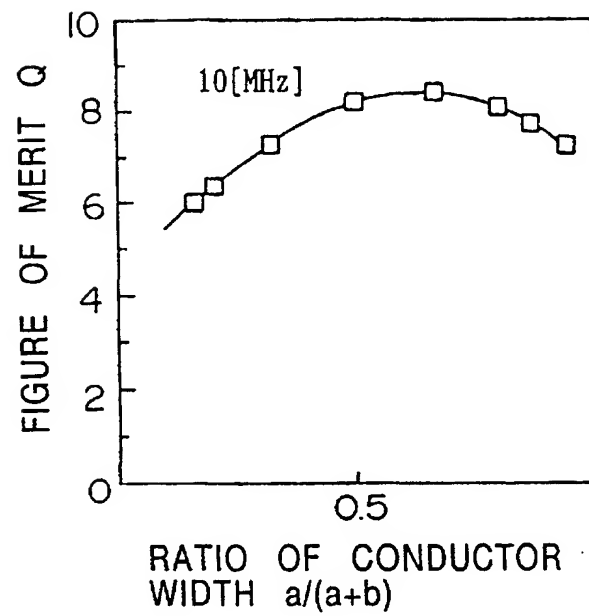


FIG. 7

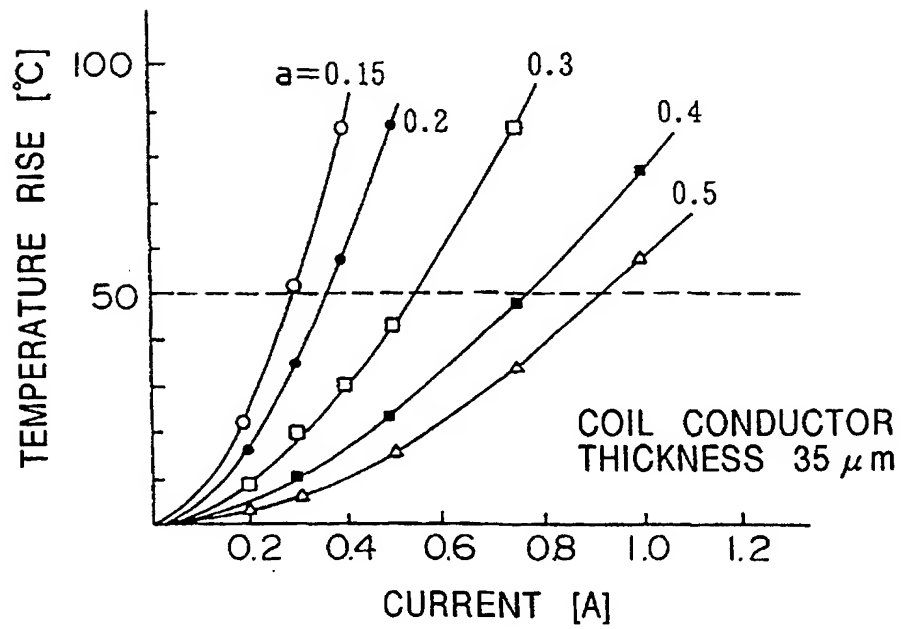


FIG. 8

